



03-06-02

GAU/1765 34
04.6.5

MEMC 3003
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of John D. Holder

Art Unit 1765

Serial No. 10/002,862

Filed November 15, 2001

Confirmation No. 4783

For **INTERMITTENT FEEDING TECHNIQUE FOR INCREASING THE MELTING RATE
OF POLYCRYSTALLINE SILICON**

March 5, 2002

TO THE COMMISSIONER OF PATENTS AND TRADEMARKS,

SIR:

INFORMATION DISCLOSURE STATEMENT

In accordance with 37 C.F.R. 1.97 and 1.98 and MPEP 609, and in compliance with the duty of disclosure set forth in 37 C.F.R. 1.56, applicant submits copies of the references listed on the attached PTO/SB/08A for consideration by the Patent and Trademark Office in the above-entitled application and to be made of record therein.

Respectfully submitted,

Steven M. Ritchey, Reg. No. 46,321
SENNIGER, POWERS, LEAVITT & ROEDEL
One Metropolitan Square, 16th Floor
St. Louis, Missouri 63102
(314) 231-5400

SMR/cak

Express Mail Label No. EV015167687US

RECEIVED
MAR 14 2002
TC 1700

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(use as many sheets as necessary)



Sheet	1	of	2	Attorney Docket No.	MEMC 3003
-------	---	----	---	---------------------	-----------

RECEIVED
MAR 14 2002
TC 1780

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code ² (if known)		
	1	5,059,410		Boone et al.	10/22/1991
	2	5,087,321		Kamio et al.	02/11/1992
	3	5,087,429		Kamio et al.	02/11/1992
	4	5,126,114		Kamio et al.	06/30/1992
	5	5,152,433		Mohri	10/06/1992
	6	5,462,010		Takano et al.	10/31/1995
	7	5,588,993		Holder	12/31/1996
	8	5,858,087		Taguchi et al.	01/12/1999
	9	5,902,395		Nagai et al.	05/11/1999
	10	5,919,303		Holder	07/06/1999
	11	6,110,272		Aikawa et al.	08/29/2000

Examiner Signature		Date Considered	
--------------------	--	-----------------	--

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

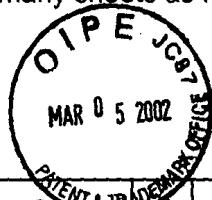
¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, D.C. 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, D.C. 20231.

PTO/SB/08A

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(use as many sheets as necessary)



Sheet

2

2

Complete if Known

Application Number	10/002,862
Filing Date	November 15, 2001
Confirmation Number	4783
First Named Inventor	John D. Holder
Group Art Unit	1765
Examiner Name	

MEMC 3003

RECEIVED
MAR 14 2002
AC 1700

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Office	Number ⁴	Kind Code ² (if known)		
12	EP	0 406 824	A1	Mohri	09/01/1991	
13	DE	42 01 546	A1	Klöpsch et al.	07/23/1992	

OTHER ART - NON PATENT LITERATURE DOCUMENTS		
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.

Examiner Signature	Date Considered
--------------------	-----------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, D.C. 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, D.C. 20231.